ISSUE CLASSIFICATION	
Class	Subclass

PATENT NUMBER

U.S. UTILITY Patent Application

O.I.P.E.	PATENT DATE
SCANNED 4/20/00 O.A.	

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/817056		~~257~~ 438	687	2813	Thanh Nguyen

APPLICANTS: Kai Yang, Darrell Erb, Fei Wang

TITLE: Stabilizing fluorine etching of low-k materials

ISSUING CLASSIFICATION

ORIGINAL

CROSS REFERENCE(S)

DRAWINGS

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